FOGALE nanotech

Lensview system

Lens assembly thickness & airgap semi-automatic measurement



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Using a combination of IR interferometry and patented optical head, Lensview can address critical microlens manufacturing process steps or to validate a new lens assembly design.

Measurement: The patented optical head is combined with imaging and metrology in the same optical to reach the best in class spot centering capability.

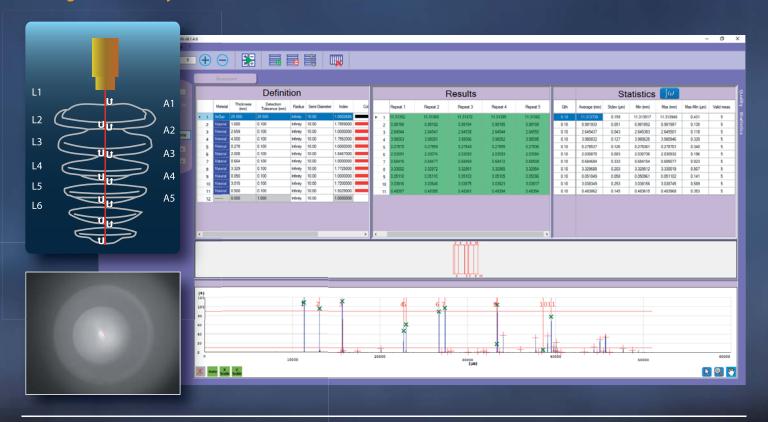
Accuracy & Precision: The centering operation is performed by combining visual spot positioning and reflected signal analysis.

Reliability & Maintainability: LeNSVIEW mechanical set-up allows easy reliable alignment along with low maintenance.

Data management: "Easy to use" software makes measurement easier and data exportation in several format for reporting.

Measurement range: From 20 μm to 200 mm.

Single or multi-layers measurement



Technical specifications

Optoelectronic units	Lensview ED	Lensview LS	Lensview HR
Measurement range	30 μm-5 mm	30 μm-200 mm	20 μm-6 mm
Accuracy	0.07 μm	0.2 μm	0.07 μm
Repeatibility 3 sigma	<0.2 μm	0.6 μm	<0.2 μm

